



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q78706

Tadahiro KEGASAWA, et al.

Appln. No.: 10/725,053

Group Art Unit: 1732

Confirmation No.: 2949

Examiner: Mark Eashoo

Filed: December 02, 2003

For: METHOD AND APPARATUS FOR FORMING RESIN FILM

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

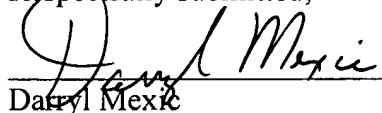
In response to the Restriction Requirement, dated March 24, 2006, Applicants elect Group I, claims 1-5 for examination. This election is made without traverse.

Applicants reserve the right to file a Divisional Application directed to non-elected claims.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

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Respectfully submitted,


Darryl Mexic

Registration No. 23,063

WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: April 24, 2006